



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIBDATASHEET**CONFIRMATION NO. 8557**

Bib Data Sheet

SERIAL NUMBER 10/645,911	FILING DATE 08/22/2003 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 047297-0137
-----------------------------	---------------------------------------	--------------	------------------------	---------------------------------------

APPLICANTS

Hisatsugu Kurita, Shibata-shi, JAPAN;

Manabu Hirasawa, Shibata-shi, JAPAN;

Hiromi Nagahama, Shibata-shi, JAPAN; Koji Izumome, Shibata-shi, JAPAN;

Takao Ino, Yokohama-shi, JAPAN;

Jyunsei Yamabe, Yokohama-shi, JAPAN;

Naoya Hayamizu, Yokohama-shi, JAPAN;

Naoaki Sakurai, Yokohama-shi, JAPAN;

** CONTINUING DATA *MK (none)* *****

** FOREIGN APPLICATIONS *MK (verified)* *****

JAPAN 2002-259579 09/05/2002
 JAPAN 2002-299769 10/15/2002
 JAPAN 2003-005323 01/14/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/21/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>MK</i> Examiner's Signature Initials	JAPAN	7	4	1

ADDRESS

22428
 FOLEY AND LARDNER
 SUITE 500
 3000 K STREET NW
 WASHINGTON , DC
 20007

TITLE

Silicon wafer cleaning method